## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

of

In re the Application of

## IAP9 Rec'dPCT/PTO 0 6 APR 2006

Kanako KITAYAMA et al.

Application No.: New U

U.S. National Stage

PCT/JP2005/003983

Filed: April 6, 2006

Docket No.: 127642

For:

SEMICONDUCTOR DEVICE MANUFACTURING METHOD

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. One or more reference cited herein was cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information. See References 1-4.
- 3. An English language Abstract of one or more non-English language reference is attached hereto. See References 1-4.
- 4. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 1-4.

Respectfully submitted,

James A. Oliff Registration No. 27,075

Joel S. Armstrong Registration No. 36,430

JAO:JSA/jrb

Date: April 6, 2006

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## 10/574893 IAP9 Rec'd PCT/PTO 0 6 APR 2006 Sheet \_1\_\_\_ of \_1\_\_\_

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	INFORMATION DISCLOSURE STATEMENT							05/003983	
	(Use several sheets if necessary)			APPLICANTS Kanako KITAYAMA et al.					
				FILING DATE April 6, 2006					
U.S. PATENT DOCUMENTS									
Examiner Initials	Cite No.	Document Number	Da	te		Name			
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FOREIGN PATENT DOCUMENTS									
Examiner Initials	Cite No.	Document Number	Da	·	Country		With English Abstract	With English Translation	
	1	JP A 2001-089859	04/03/2001		Japan		х	х	
	2	JP A 2004-039788	02/05/2004		Japan		х	х	
	3	JP A 2003-051452	02/21/2003		Japan		х	х	
	4	JP A 2001-123271	05/08/2001		Japan	-	х	х	
	OTHER DOCUMENTS								
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Date: April 6, 2006